OIPE
OCT 0 3 2003
PATENT & TRADEMARK OFFICE
JC117

Attorney's Docket No.: 005794 ALRT/ETCH/CONE/ Patent
Confirmation No.: 3777

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	
Mark N. Kawaguchi, et al.	
	Examiner: Allan W. Olsen
Application No: 09/978,121	
	Art Unit: 1763
Filed: October 15, 2001	
For: A METHOD OF PHOTORESIST REMOVAL IN THE PRESENCE OF A DIELECTRIC LAYER HAVING A LOW K-VALUE	

RECEIVED
OCT 0 8 2003
TC 1700

Mail Stop: Non-Fee Amendment
Commissioner For Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated June 30, 2003, Applicant respectfully requests that the above-identified application be amended as follows and that the following remarks be considered:

FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to MS: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on:

September 30, 2003
Date of Deposit

Dianne Neathery
Name of Person Mailing Correspondence

Dianne Neathery
Signature

September 30, 2003
Date